

PATENTS-Benard Eastlund

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<http://www.eastlundscience.com/PATENTS.html>

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THE ARCO PATENTS (ASSIGNED TO APTI)

Eastlund combined the ideas of MEV electrons in space with the
technology to generate MEV electrons
using electromagnetic waves to create the idea of a missile shield and
other applications of MEV
electrons by inventing a large antenna array in Alaska to project RF
electromagnetic waves to intersect
with the earth's geomagnetic field at high altitude. The subsequent
relativistic electrons would destroy

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enemy missiles if they intersected with missile trajectories. See HAARPMEVELECTRONS.

The patents are:

"Method for Producing a Shell of Relativistic Particles at an Altitude Above the Earths Surface"

Bernard J. Eastlund inventor, US Patent Number: 5,038,664 Issue Date: 8/13/91, Assignee: APTI, Inc.

"Method and Apparatus For Altering a Region in the Earth's Atmosphere, Ionosphere, and/or

Magnetosphere" Bernard J. Eastlund inventor, US Patent Number: 4,686,605 Issue Date: 8/11/87

Assignee: APTI, Inc.

"Method and Apparatus For Creating an Artificial Electron Cyclotron Heating Region of Plasma"

Bernard J. Eastlund and Simon Ramo inventors, Patent Number: 4,712,155 Issue Date: 1/28/85

Assignee: APTI, Inc.

Note that all of these patents were filed before any subcontractors were involved with the project.

The patent issued in 1991 had been held up because it was classified as secret for 5 years.

MEV ELECTRONS

MEV ELECTRONS the HAARP system, or a system like it only larger, could accelerate copius

numbers of MEV electrons along magnetic field lines in the atmosphere, then, in our opinion, this could

be the greatest threat to modern military satellite technology. A

geosynchronous satellite could be

eliminated within 20 minutes. There is some indication that other

countries, such as China are working

on such technologies. See HAARPMEVELECTRONS

<http://www.eastlundscience.com/HAARP.html>